

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L6	179	(359/223,224,230,290,291,295,298,846).ccls. and @pd>="20050303"	US-PGPUB; USPAT	OR	OFF	2005/07/13 15:21
L7	1765	((mems or mem or microelectromechanical or microelectricalmechanical or (micromechanical with (mirror\$1 reflect\$3)) or (micro adj2 electro adj2 mechanical) or (micro adj2 electrical adj2 mechanical) or (micro adj2 mechanical))) and ((deform\$4 with (surface\$1 plate\$1 mirror\$1)) same (actuat\$3 electrode\$1))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:39
L8	109777	(mems or mem or microelectromechanical or microelectricalmechanical or micromechanical or (micro adj2 electro adj2 mechanical) or (micro adj2 electrical adj2 mechanical) or (micro adj2 mechanical)) same (actuat\$3 electrode\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:05
L9	6760	L8 and ((mirror\$1 micromirror\$1 reflect\$3) same (actuat\$3 electrode\$1))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:05
L10	45	L9 and ((mirror\$1 micromirror\$1 reflect\$3) same (deform\$3 bend\$3 (chang\$3 near\$3 shape))) and ((mirror\$1 micromirror\$1 reflect\$3) same (rotat\$3 twist\$3 tilt\$3 pivot\$3)) and @pd>="20050303"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:05
L11	109777	(mems or mem or microelectromechanical or microelectricalmechanical or micromechanical or (micro adj2 electro adj2 mechanical) or (micro adj2 electrical adj2 mechanical) or (micro adj2 mechanical)) same (actuat\$3 electrode\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:07
L12	45	L11 and (second adj2 actuator) and @pd>="20050303"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:06

L13	87	10 12	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/13 17:07
L14	95	((((mems or mem or microelectromechanical or microelectricalmechanical or (micromechanical with (mirror\$1 reflect\$3)) or (micro adj2 electro adj2 mechanical) or (micro adj2 electrical adj2 mechanical) or (micro adj2 mechanical)))) and actuat\$3 and (first with electrode\$1) and (second with electrode\$1)).clm.	US-PGPUB	OR	OFF	2005/07/13 17:43
L15	3	((((mems or mem or microelectromechanical or microelectricalmechanical or (micromechanical with (mirror\$1 reflect\$3)) or (micro adj2 electro adj2 mechanical) or (micro adj2 electrical adj2 mechanical) or (micro adj2 mechanical)))) and actuat\$3 and (first with electrode\$1) and (second with electrode\$1) and ((deform\$4 chang\$3) near3 (shape\$1 contour))).clm.	US-PGPUB	OR	OFF	2005/07/13 17:52
L16	430	359/198.ccls.	US-PGPUB; USPAT	OR	OFF	2005/07/13 17:52